IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/535,015

Filed: March 24, 2000

For: METHOD OF MANUFACTURING A

SEMICONDUCTOR DEVICE

Group Art Unit: 2811

Examiner: S. Crane

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal

Service with sufficient postage as First Class Mail in an envelope addressed to:

Commissioner for Patents, P.O. Box 1450,

Alexandria, VA 22318-1450, on June 1, 2006.

add on Stamper

INFORMATION DISCLOSURE STATEMENT AND CORRECTION OF PREVIOUSLY SUBMITTED INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

This Information Disclosure Statement is being submitted with an RCE. Therefore, no fee is required.

Further to the Correction to Previously Submitted Information Disclosure Statement filed April 28, 2006, it has come to applicant's attention that the Correction included the following inaccuracy:

1) The article to Nemanich et al., Structure and Growth of the Interface of Pd on a-SIH, cited the date as June 1981. The complete date is June 15, 1981.

The above inaccuracy is corrected on the 1449 Form attached hereto. The Examiner is requested to initial the attached PTO Form 1449 evidencing consideration of the above reference and line through this reference on the previously submitted

Information Disclosure Statements to ensure that the correct information is printed correctly on any issued patent.

Respectfully submitted,

Eric J. Robinson Reg. No. 38,285

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Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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Substitute for form 1449A/PTO				Complete if Known		
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INFORMATION DISCLOSURE				Filing Date	March 24, 2000	
(use as many sheets as necessary)				First Named Inventor	Shunpei YAMAZAKI et al.	
			ssary)	Group Art Unit	2811	
				Examiner Name	S. Crane	
Sheet	1	of	1	Attorney Docket Number	0756-2131	

	U.S. PATENT DOCUMENTS				TS		
OIP	Examiner Faitials App	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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	~ £ 3006 %	3	5,728,610		Gosain et al.	03/17/1998	
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		OTHER PR	RIOR ART - NON PATENT LITE	RATURE DOCUMENTS		
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NEMANICH, R.J. et al., Structure and Growth of the Interface of Pd on a-Si American Physical Society - Physical Review, Vol. 23, No. 12, Pages 6828-June 15, 1981.			·			

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.